



UNITED STATES PATENT and TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND
DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
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PAPER NO. 6

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| In re Application of | : | |
| William M. Traut et al. | : | DECISION |
| Serial No. 10/073,184 | : | ON |
| Filed: February 13, 2002 | : | PETITION |
| For: VENT FOR AND METHOD OF | : | UNDER 708.02,V |
| CONCEALING AND VENTING A SEPTIC | : | |
| SYSTEM | : | |

This is in response to the petition filed March 14, 2002, requesting that the above-identified application be granted Special Status under Sections 708.02 (V) of the MPEP and 37 CFR 1.102(c).

The petition has been considered and found to comply with the requirements set forth under the above-noted section. Accordingly the petition is **GRANTED**.

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